

Electronic Patent Application Fee Transmittal

Application Number:	10700136			
Filing Date:	03-Nov-2003			
Title of Invention:	WIRING STRUCTURE ON SEMICONDUCTOR SUBSTRATE AND METHOD OF FABRICATING THE SAME			
First Named Inventor/Applicant Name:	Tomio Matsuzaki			
Filer:	Douglas Holtz/JD Dholakia			
Attorney Docket Number:	03663/LH			
Filed as Large Entity				
Utility Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Request for continued examination	1801	1	790	790
Total in USD (\$)				790